



Computational Modeling of Metal Oxidation

Youhai Wen and Tianle Cheng

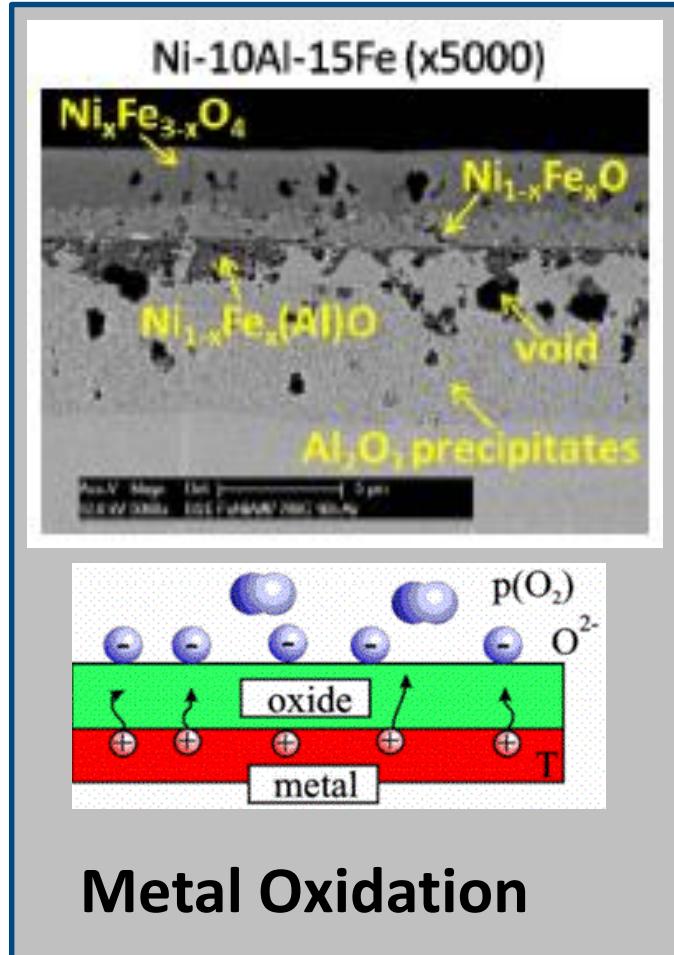
US Department of Energy - NETL

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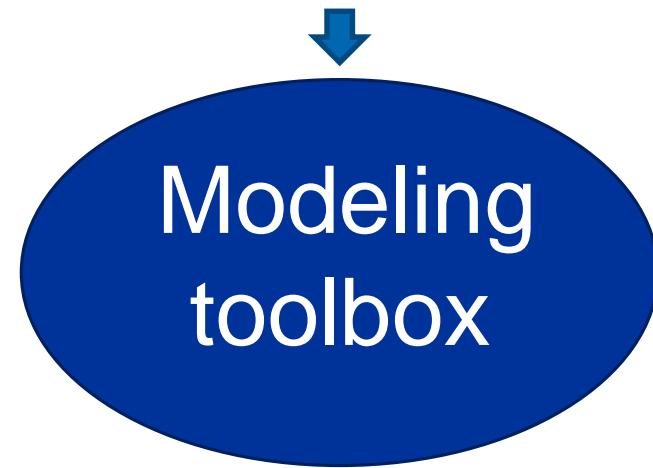
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Metal Oxidation Modeling Challenge



(Source: Internet)

Material's operating conditions



↓

Material Performance

Modeling Toolbox

Component Life Prediction

with representative
composition/microstructure
under a given environment

Oxidation
model for pure
metals

Multi-oxidant
modeling

Mechanical
response
modeling

Oxidation model
for alloys

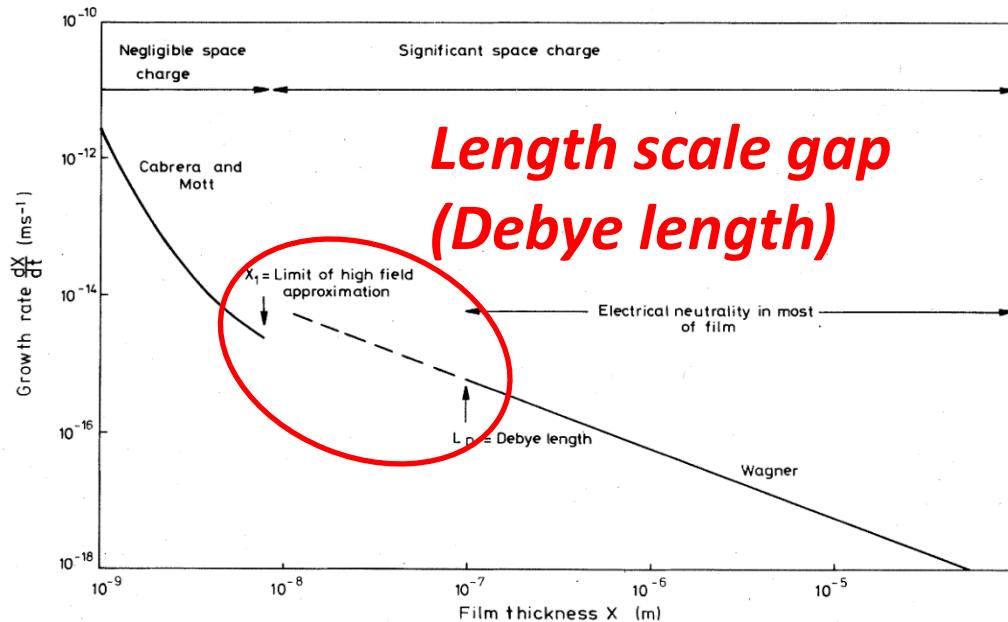
Microstructure
effect modeling

State-of-the-art of Computational Modeling

Cabrera
-Mott
Theory

*Moderate
film thickness*

Wagner
Theory



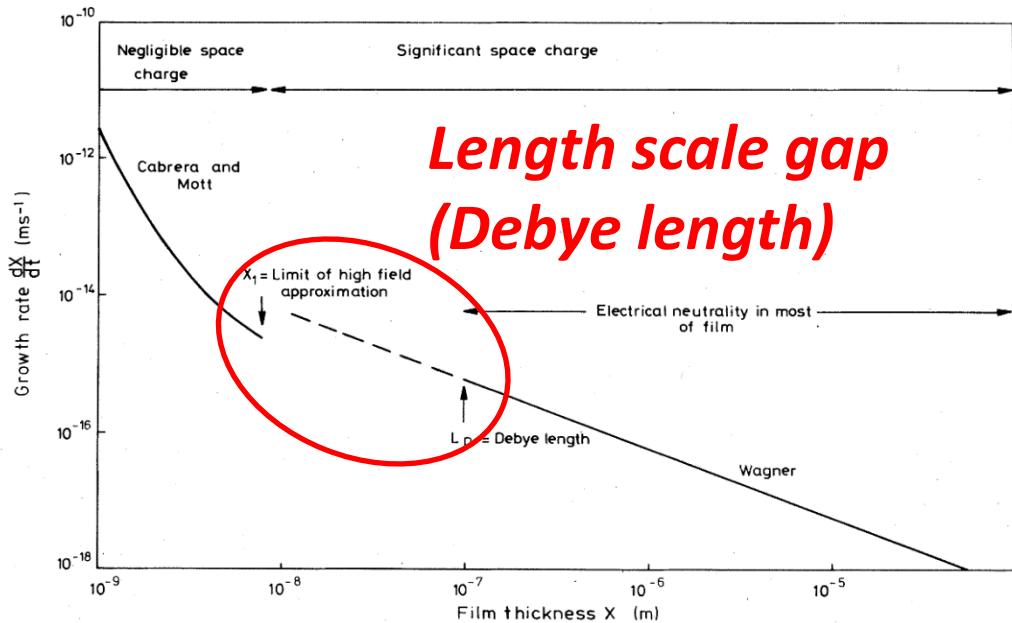
In this intermediate length regime, some common simplifications are not applicable such as local charge neutrality or constant electric field.

Length Scale Gaps in Oxidation Theories

Cabrera
-Mott
Theory

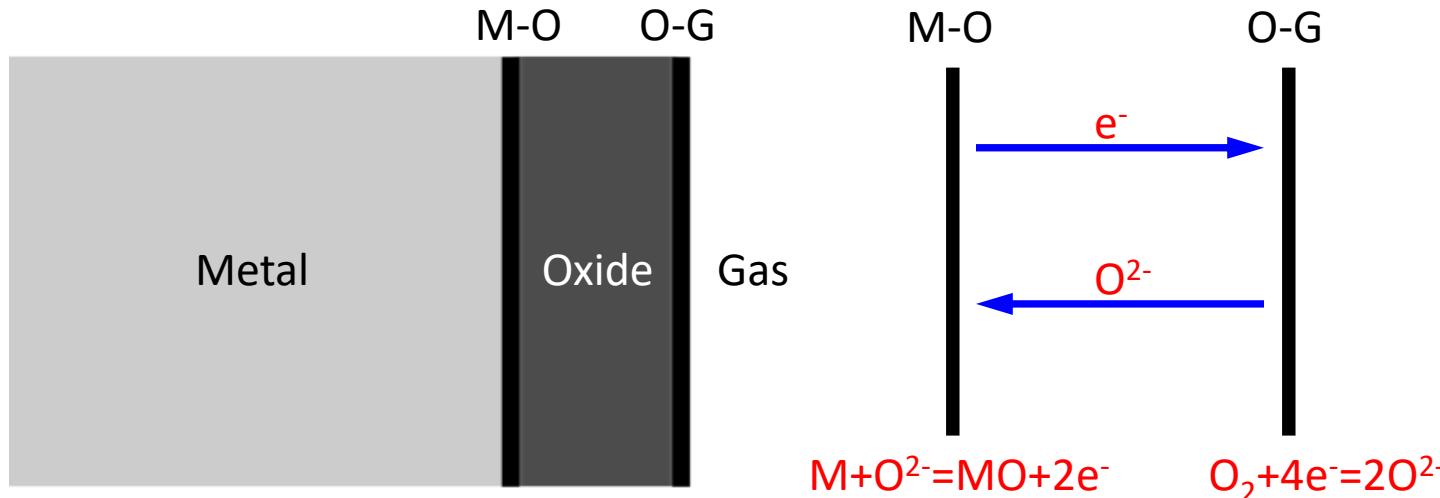
*Moderate
film thickness*

Wagner
Theory



Moderate film thickness regime:
The coupling of charge interaction, ionic diffusion, and chemical reaction have to be addressed.

Oxidation Modeling in Pure Metals



**Coupling
physics with
no viable
simplification**

- Chemical reaction
- Mass transport
- Charge interaction
- Evolving structure
- Evolving electric field

Phase-field Method

Governing Equations for Metal Oxidation

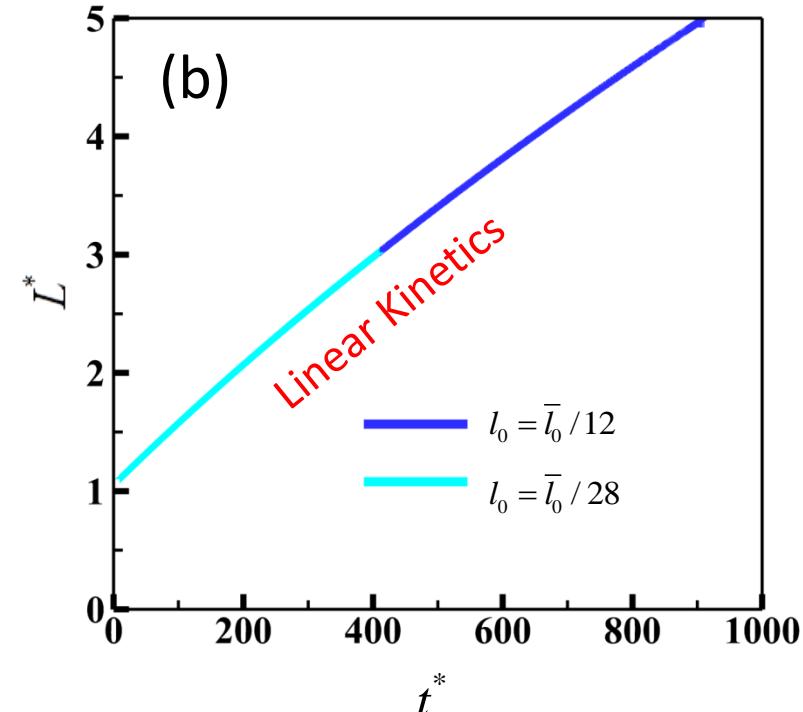
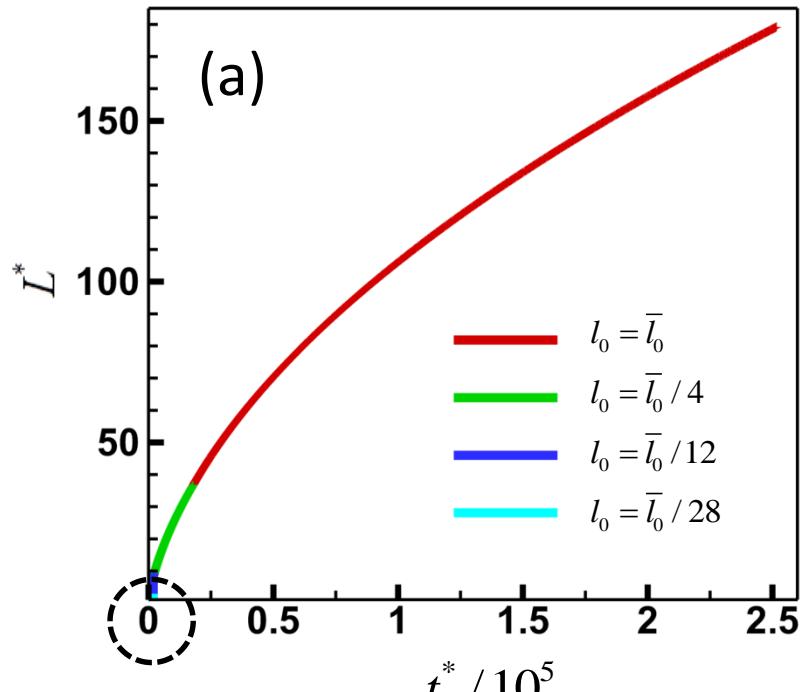
	Reaction	Diffusion + Electromigration
$[X^-]$:	$\frac{\partial c_1}{\partial t} = K_I \Lambda_\zeta (Q \tilde{c}_2 - \tilde{c}_1) - K_{II} \Lambda_\eta \tilde{c}_1 + \nabla \cdot (\tilde{D}_1 \nabla \tilde{c}_1) - \frac{e}{k_B T} \nabla \cdot (D_1 c_1 z_1 \mathbf{E})$	
$[e^-]$:	$\frac{\partial c_2}{\partial t} = -K_I \Lambda_\zeta (Q \tilde{c}_2 - \tilde{c}_1) + K_{II} \Lambda_\eta \tilde{c}_1 + \nabla \cdot (\tilde{D}_2 \nabla \tilde{c}_2) - \frac{e}{k_B T} \nabla \cdot (D_2 c_2 z_2 \mathbf{E})$	
$[c^+]$:	$\frac{\partial c_3}{\partial t} =$	$\nabla \cdot (D_3 \nabla c_3) - \frac{e}{k_B T} \nabla \cdot (D_3 c_3 z_3 \mathbf{E})$
$[M]$:	$\frac{\partial \eta}{\partial t} =$	$-K_V K_{II} \Lambda_\eta \tilde{c}_1 + M_\eta \nabla^2 (\partial f / \partial \eta - \beta \nabla^2 \eta)$

The electric field, satisfying Poisson's equation, is solved by **an efficient numerical scheme** for arbitrary **dielectric heterogeneity**

$$\nabla \cdot [\epsilon(\mathbf{r}) \nabla \varphi(\mathbf{r})] + \rho_f(\mathbf{r}) = 0$$

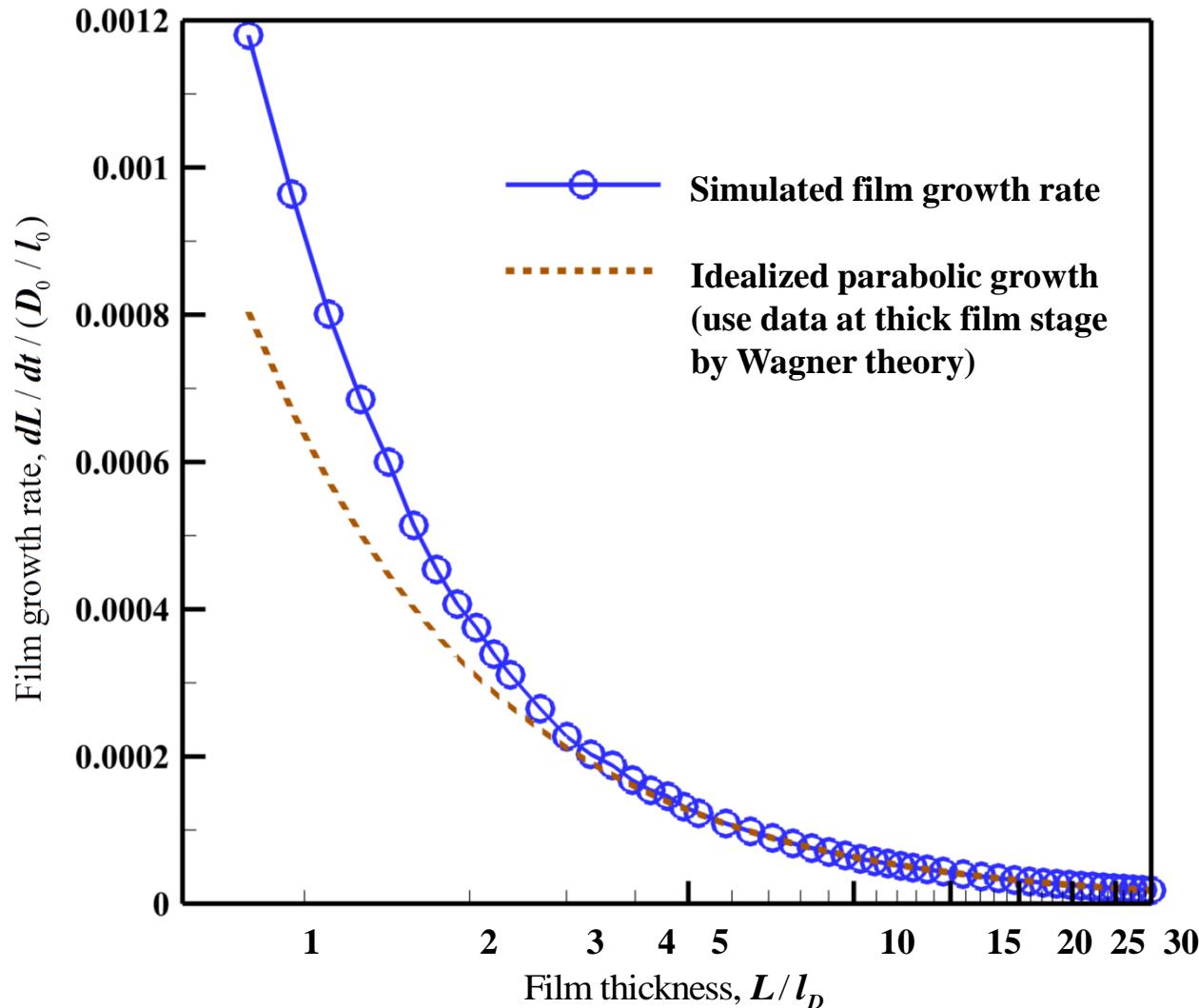
Simulated Results on Oxidation Kinetics Modeling

Linear → Parabolic kinetics Transition



T Cheng, Y Wen and J Hawk, J. Phys. Chem. C 118(2014), 1269-1284

Oxide Growth Rate vs. Film Thickness

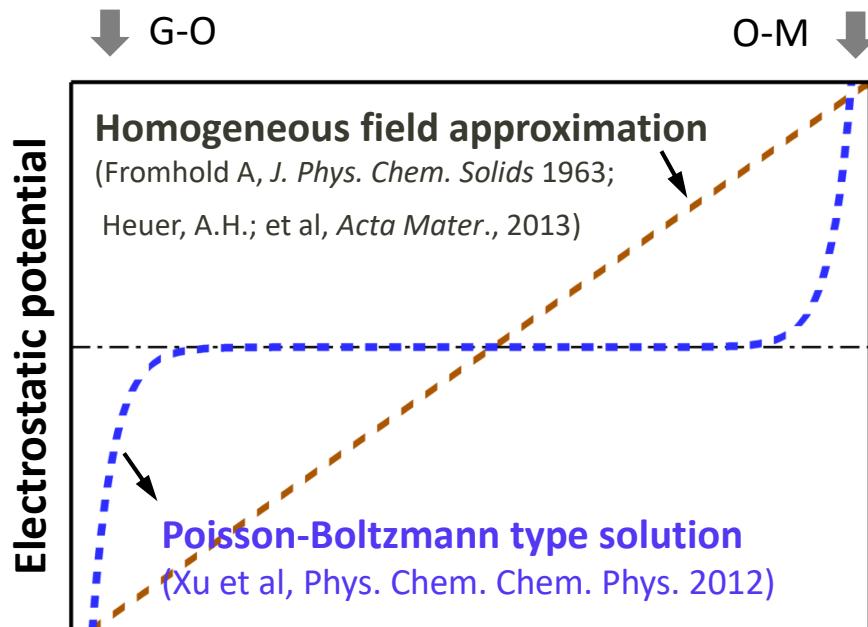


Space charge effect can not be ignored

Results on Electric Field in a Growing Oxide Film

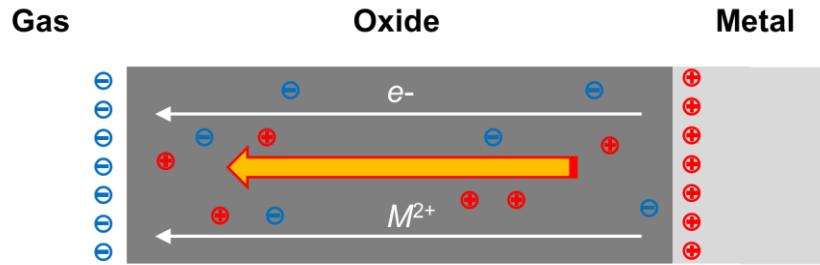
Two dominant representations:

- Homogeneous electric field across the film
- Electric field decays to zero exponentially away from the surface or interface

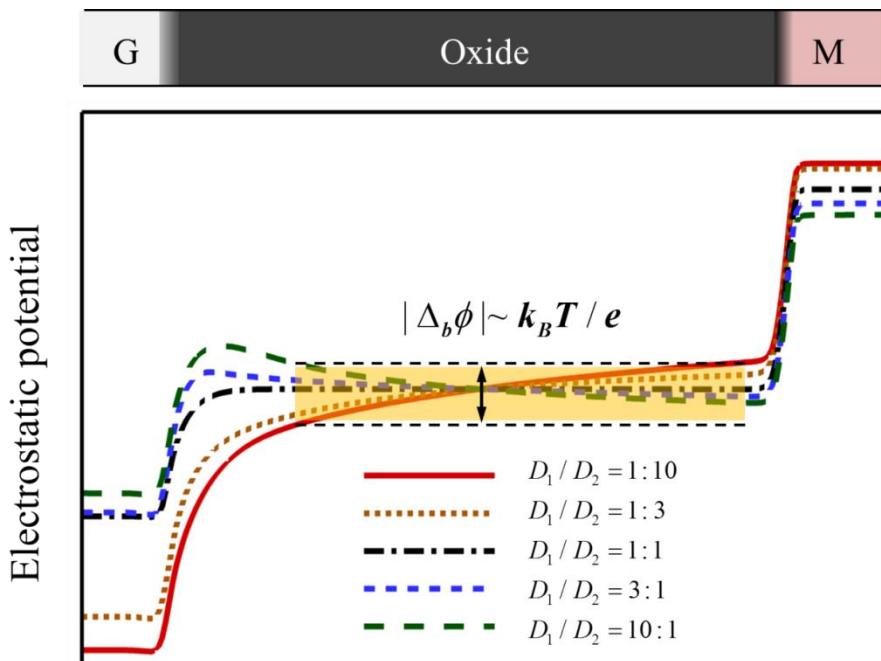


Kinetics is missing!

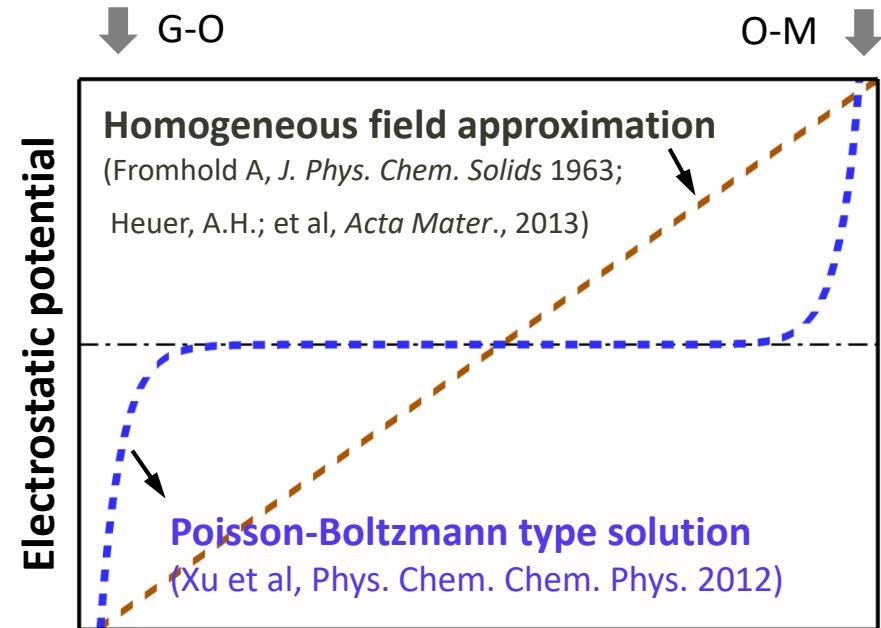
Electric Field in a Growing Oxide Film



Outward diffusion of metal ions and electrons with different valences



Simulated electrostatic potential profiles with different defect mobility ratios.



T Cheng, Y Wen, J. Phys. Chem. Lett. 5 (2014), 2289-2294

On-going Effort: Internal → External Oxidation

Significance and Overview

Fe-, Ni-, or Co-base structural alloys applied at high temperatures invariably rely on formation of an externally oxidized, slowly growing layer (mainly Al_2O_3 or Cr_2O_3), for oxidation protection. Consequently, the transition from internal to external oxidation is a basis for design of those alloys.

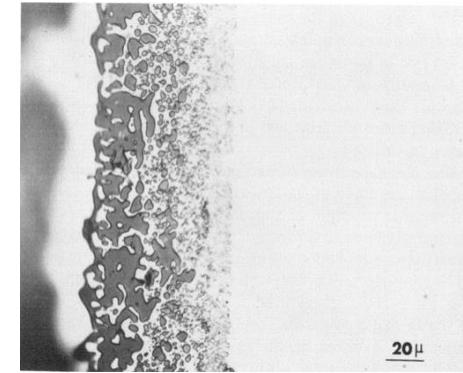


Fig. 1 Transition from internal to external oxidation in Co-8.99%Ti at 900°C for 528h, (G.H. Meier et al, 1976)

Outstanding challenges to model this with Phase-Field:

- a) Modeling plasticity due to volume expansion with oxidation
 1. Guo, X. H.; Shi, S. Q.; Ma, X. Q, Appl. Phys. Lett. 2005, 87;
 2. Yamanaka, A.; Takaki, T.; Tomita, Y., Mater. Sci. Eng. A-Struct. Mater. Prop. Microstruct. Process. 2008, 491, 378.
- **Elastic-perfect plasticity – No hardening behavior**
- **Deviatoric stress-free strain only – No dilatational deformation**



On-going Effort: Internal → External Oxidation

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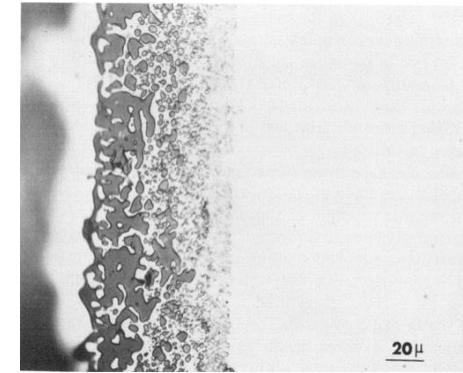
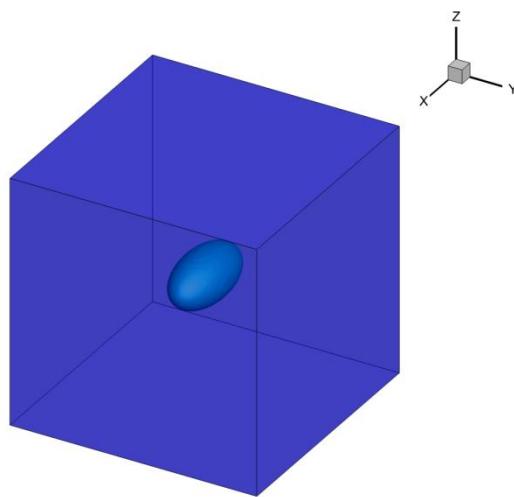


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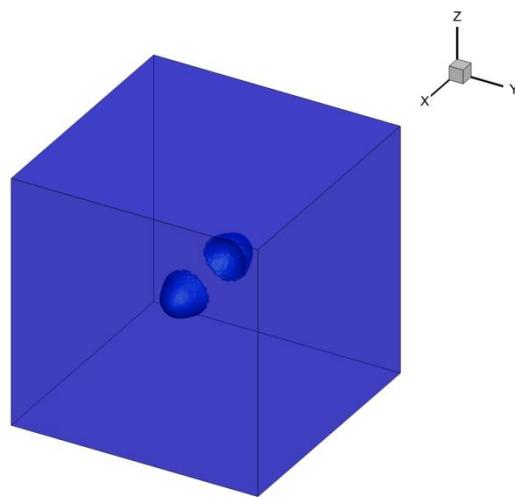
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- b) Modeling coherency loss involving transition between coherent, semicoherent, and incoherent interfaces

3D Phase-field Elasto-Plasticity Simulation Demo



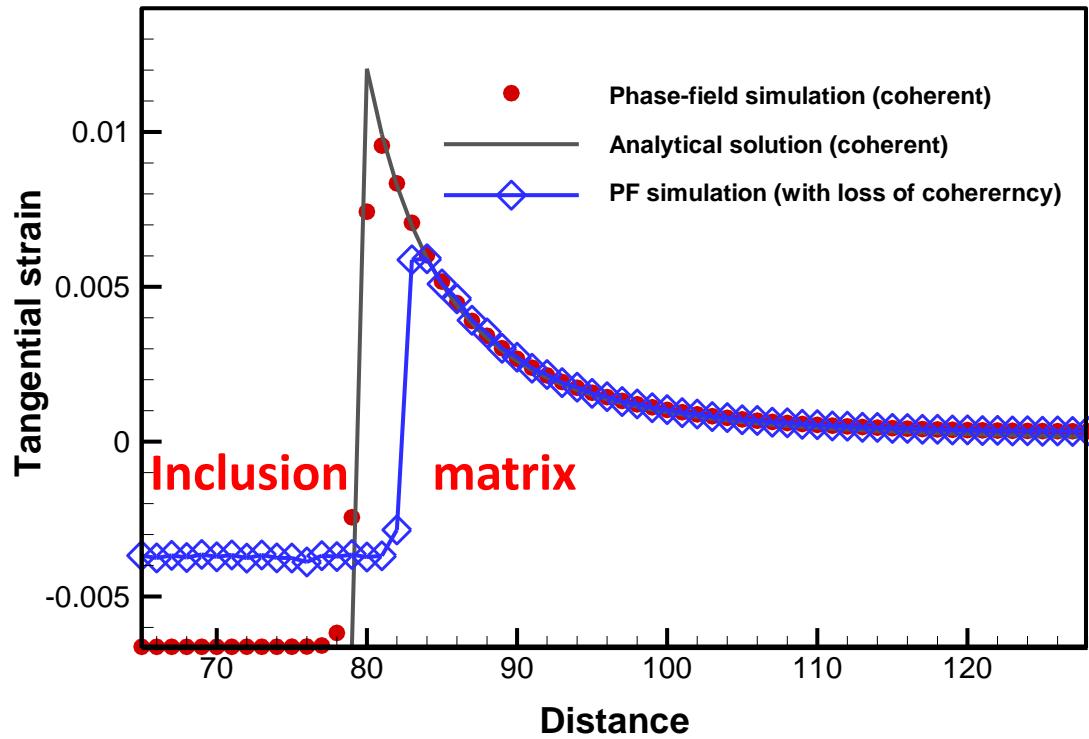
Ellipsoidal inclusion undergoes
5% elongation along x-axis



Plastic deformation zone in the matrix

Interface Coherency Effect on Elastic Energy

A 3-D Simulation Demo



Tangential strain for a spherical inclusion with isotropic eigenstrain of 2% volume change

Even for a dilatational inclusion, coherency loss can appreciably reduce elastic energy.

Summary

- Developed a *simulation capability* based on Phase-Field Method to simulate oxidation in simple systems – Oxidation kinetics and electric field
- *Further development* of the model is on-going to advance this model into a useful tool that can be used to eventually predict the life of an alloy

Electric Field in a Growing Oxide Film

Two dominant representations:

- Homogeneous electric field across the film
- Electric field decays to zero exponentially away from the surface/interface assuming thermodynamic equilibrium

$$J_i = -D_i \nabla c_i + \varpi_i \mathbf{E} c_i \quad \text{Flux equations}$$

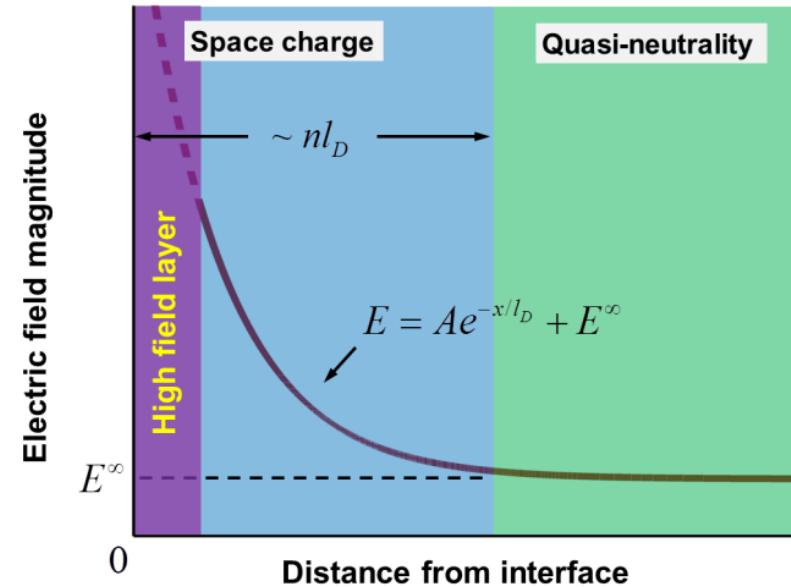
$$\epsilon \nabla \bullet \mathbf{E} = \sum_i z_i e N_A c_i \quad \text{Linearized Poisson Boltzmann}$$

- Two negatively charged transporting species with identical valences: i.e. $z_1=z_2=-1$ for electrons and interstitial anions
- Assume coupled-current condition

$$E = A e^{-x/l_D} + E^\infty$$

$$E^\infty = \frac{k_B T}{e \bar{c}} \frac{D_1 - D_2}{D_1 D_2} J^\infty$$

$$l_D = \sqrt{\epsilon k_B T / N_A e^2 \bar{c}}$$



Schematic of the electric field near an interface with a decaying screening term plus a permanent remnant term .